## Notice of References Cited Application/Control No. 10/052,673 Examiner Demetrius R. Pretlow Applicant(s)/Patent Under Reexamination CHU, DAVID C. Art Unit Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number	Date	Name	Classification
Ĺ		Country Code-Number-Kind Code	MM-YYYY	Name	Ciassification
	Α	US-2003/0098981	05-2003	Chu	356/496
	В	US-6597459-B2	07-2003	Demarest	356/498
	С	US-2002/0089671 /	07-2002	Hill	356/486
	D	US-6573996-B1	06-2003	Deliwala et al	356/487
	Ε	US-6137574	10-2000	Hill	356/486
	F	US-2003/0086646	05-2003	Rothenberg et al	385/87
	G	US-2001/0028759	10-2001	Cao	385/24
	. Н	US-4912468	03-1990	Rust	341/119
	-	US-5991033	11-1999	Henshaw et al	356/487
	J	US-6191415-B1 /	02-2001	Stridsberg	250/231.13
	К	US-5757489	05-1998	Kawakami	356/500
	L	US-2002/0021449	02-2002	Demarest	356/498
	М	US-			

## **FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Q					
	R					
	s					
	T					

## NON-PATENT DOCUMENTS

TOTAL							
*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)					
	υ						
	V						
	w						
	х						

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.